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Differential Interferometer SP 5000 DI Series



System parameter	SP 5000 DI	SP 5000 DI/F
Measurement range	0 m to ≥ 5 m	
Resolution	5 pm*	
Angular measurement range with reflector with plane mirror (recommended distance ≤2 m)	±12.5° ** ±1.5 arcmin 0.001 arcsec***	±15° ** ±1.5 arcmin 0.0015 arcsec***
Angular resolution		
Beam distance (standard)	21 mm	14 mm
Temperature sensitivity	<20 nm/K	<10 nm/K
Wavelength	632.8 nm	
Frequency stability of the HeNe laser (after warm-up time)	2·10 ⁻⁸	
Warm-up time of the HeNe laser	1020 min	
Operating temperature range	1530°C	
Maximum displacement speed of measuring reflector	3 m/s	
Geometric Data		
Dimensions (L x W x H):		
Sensor head (with base plate)	[150 x 140 x 43] mm	[110 x 65 x 33] mm
Electronic evaluation and supply unit EU (standard)	[450 x 400 x 150] mm	
Mass:		
Sensor head	2.0 kg	1.1 kg
Base plate Electronic evaluation and supply unit EU (standard)	1.5 kg - ca. 8 kg	
Electrical Data		
Interfaces standard other interfaces on request (/R)	RS232C, USB	
Cable length between sensor head and electronics unit	3 m, optionally up to 10 m	
Power supply	100240 VAC / 4763 Hz	
Laser safety class according to EN 60825-1:2014 and ANSI Z136.1 (CDRH)	2M II	

^{*}in frequency domain

09/2019 · Subject to change.





SP 5000 DI

Product information

Extremely stable laser interferometer for high-precision length or angle measurements

Laser interferometer measurement system

SP 5000 DI

Our ultra-stable differential laser interferometer SP 5000 DI is characterised by its unique thermal stability and can be used for long-term measurements in research and development, such as for material testing.

Thanks to its design, with an external reference beam, the measurement system can be placed at a longer distance from the measurement location without significantly affecting



the resolution or stability of the measurement. The length resolution of the interferometer is 5 pm and this can be achieved even under normal laboratory conditions thanks to the differential principle of the measurement system.

The measurement range for length measurement is several meters if tilt-invariant reflectors are used for the measurements. The system has a modular design and can therefore be adapted to specific measurement tasks.

Adjustments can be made simply and with long-term stability. The construction of multi-axis systems on the basis of the SP 5000 DI interferometer also allows multi-coordinate measurements.



with plane-mirror
5 m
with reflector



0.1 µm/m



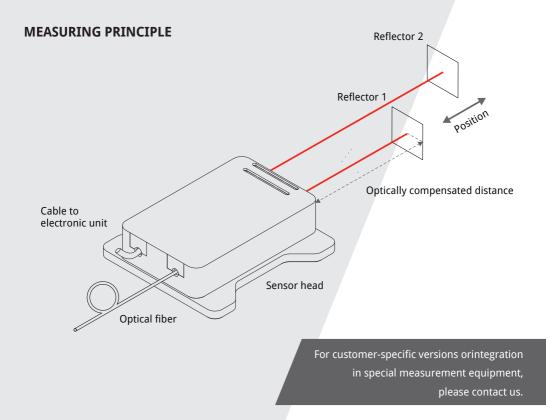
5 pm



± 1.5 arcmin
with plane-mirror
± 15°
with reflector



0.001 arcsec



Further possible applications:

- The differential laser interferometer is available as an OEM version for installation as an encoder in machine axes. The SP 5000 DI is also available as a vacuum-optimised version for taking measurements in a vacuum.
- The standard beam distance is 21 mm. We can provide other beam distances on enquiry.

Ideal for

- Long-term measurements
- Development

- Science/research
- OEM applications
- · Exacting stability requirements



For customer-specific versions, OEM applications or integration in special measurement stations, please contact us.

We will be happy to personally assist you in finding solutions for your measuring tasks.

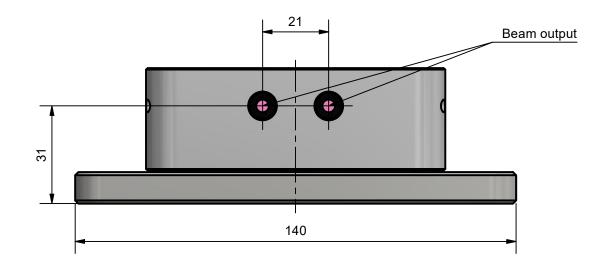
SIOS Meßtechnik GmbH Am Vogelherd 46 98693 Ilmenau / Germany

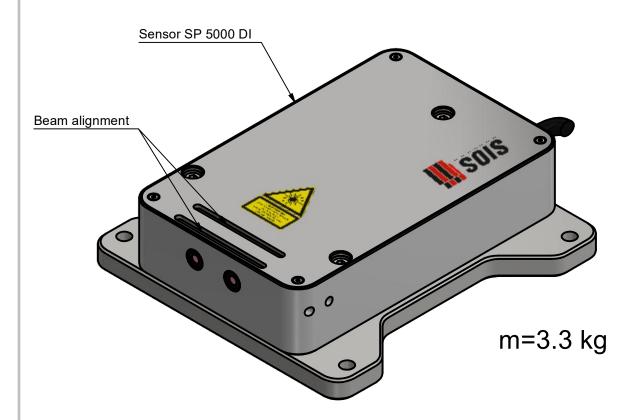
phone +49 (0) 3677 64 47-0 e-mail contact@sios.de

www.sios-precision.com

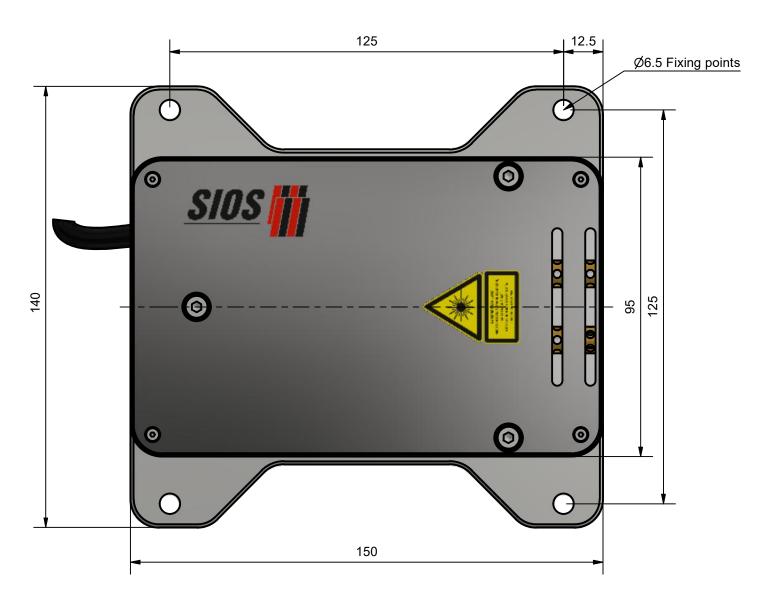
SP 5000 DI (A036254)

Beam spacing 21mm









all dimensions in mm

